



Multimodal Electrothermal Silicon Microgrippers for Nanotube Manipulation (vol 8, pg 76, 2009)

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Correction

Correction to “Multimodal Electrothermal Silicon Microgrippers for Nanotube Manipulation”

Karin Nordström Andersen, D. H. Petersen, K. Carlson, K. Mølhave, Ozlem Sardan, A. Horsewell, Volkmar Eichhorn, Sergej Fatikow, *Member, IEEE*, and Peter Bøggild

Owing to an error in the final phase of submitting the publication-ready document of the original paper [1], two authors' names were omitted from the author listing. The correct author listing is as follows:

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- [1] K. N. Andersen, D. H. Petersen, K. Carlson, K. Mølhave, O. Sardan, A. Horsewell, V. Eichhorn, S. Fatikow, and P. Bøggild, “Multimodal electrothermal silicon microgrippers for nanotube manipulation,” *IEEE Trans. Nanotechnol.*, vol. 8, no. 1, pp. 76–85, Jan. 2009.